

Search Notes**Application/Control No.**

10/695,088

Examiner

Jeff H. Aftergut

Applicant(s)/Patent under Reexamination

SATOH, HITOSHI

Art Unit

1733

SEARCHED

Class	Subclass	Date	Examiner
156	161, 163	6/11/2006	JHA
156	164,229	6/11/2006	JHA
156	494,495	6/11/2006	JHA
156	496	6/11/2006	JHA

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner